

Notice of References Cited

Application/Control No.

10/550,009

Applicant(s)/Patent Under
Reexamination
CHEN ET AL.

Examiner

KAMRAN AFSHAR

Art Unit

2617

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-2003/0012133	01-2003	Jappinen, Teemu	370/395.1
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NON-PATENT DOCUMENTS

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